



#4/DRAWINGS  
2812

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JUL 17 2002

TECHNOLOGY CENTER 280

In re application of:  
Kajiwara et al.

Art Unit: not assigned

Serial No. 09/874,174  
Filed: June 4, 2001

Examiner: not assigned

For:

Chemical Mechanical Polishing Apparatus  
And Method Having A Retaining Ring With  
A Contoured Surface

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being sent via U.S. Mail in an envelope addressed  
to Assistant Commissioner for Patents, Washington, D.C. 20231, on August 24, 2001.

Signed: Kathleen M. Smith

Kathleen M. Smith

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**SUBMISSION OF FORMAL DRAWINGS**

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

**ATTN: OFFICIAL DRAFTSPERSON**

Sir:

Enclosed please find 7 sheets of formal drawings for review by the Patent and  
Trademark Office:

- ☒ to be substituted in place of the informal drawings filed with this application.  
☐ in connection with the Notice of Patent Drawing Review (Attachment to Paper  
No. 5).  
☐ in connection with the Notice of Allowance mailed  
☐ incorporating the drawings corrections filed on

The Commissioner is hereby authorized to charge any additional fees which  
may be required by this paper, or to credit any overpayment, to Deposit Account No.  
06-1300 (No. A-70092/RMA)

Dated: August 24, 2001.

RESPECTFULLY SUBMITTED,

FLEHR HOHBACH TEST  
ALBRITTON & HERBERT LLP

By

R. Michael Ananian

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Reg. No. 35,050

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